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Research Article

Fabrication of semi-epitaxial Fe microdots on GaAs (100) substrates

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Article Info	Abstract
<i>Article history:</i> Received 16 Nov 2020 Revised 05 Feb 2021 Accepted 25 Feb 2021	Fe thin films and micro-dots were deposited onto Si (001) and GaAs (100) substrates by a combinatorial approach of lithography and e-beam deposition techniques. The base pressure in the evaporation chamber was 1x10 ⁻⁶ mbar. 50nm and 5 nm of Fe was deposited with a deposition rate of 0.1 nm/sec onto Si and GaAs, respectively. Continuous films and microdots were covered with 5 nm Cr to prevent oxidation. In-plane interfacial uniaxial magnetic anisotropy has been observed in micro-dots. Room temperature coercivity of 925 Oe has been observed in out-of-plane direction. Effects of strain and interfacial phases on inplane uniaxial anisotropy are discussed. Synthesized micro-dots could be the building blocks for next-generation magnetoelectronic devices.
Keywords: Fe/GaAs; micro-dots; magnetic anisotropy; MEMS	

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1. Introduction

Since the first observation of epitaxy in Fe films deposited on GaAs substrate, the system attracted quite a bit of attention from the research community. [1] This is due to the system's suitability to be used in spin-based magneto-electric device applications (spintronic). [2] Among the many hybrid Ferromagnetic/Semiconductor (FM/SC) systems, Fe and GaAs have special status not only due to their low lattice mismatch (η =1.4%) [3,4] but also due to the high curie temperature of Fe and widely known III-V SC substrate; GaAs. Some other possible SC substrate candidates are ZnSe, InAs, AlAs, Ge, etc.

Even though the spin injection efficiencies are reasonably lower compared to other SC devices [5], it has been shown that interface engineering could improve the spin injection efficiency of the Fe/GaAs system considerably. [6–8]

Several difficulties relating to the Fe/GaAs interface are known in the literature. A high-temperature deposition is necessary to increase the surface mobility but also causes the out-diffusion of substrate atoms into the thin film. Ergo, a wide range of deposition temperatures from -150 °C (9] to RT [1,10] and even to 580 °C [11] have been applied. It is widely known that out-diffusion of As (Even Ga) into the Fe film is a big problem since Fe atoms prefer bonding to As over Ga. [12] Even segregation of As has been observed on the surface of the Fe films. [13] Besides, it has been observed that the As segregation (surface diffusion) is possible at all temperatures (-15 °C to 175 °C) [10,14–16]

Filipe et al. [17] showed that the out-diffused As atoms form Fe-Ga-As (ferromagnetic, Hc:50 Oe, has a fraction of Fe's magnetic moment) and Fe₂As (antiferromagnetic) at the interface, thus leading to an epitaxial Fe/Reacted-phases/GaAs hybrid structure. Several

groups tried to experiment with surface temperature, surface termination, and preventive buffer layers (Ag [18], Al [9], S [19] and Oxide [20]) to prevent the out-diffusion, but either the buffer layer did not prevent the diffusion or caused other problems such as shunting the magnetoelectric device or distorting epitaxy.

The main interest of this work and the subject of ongoing scientific speculations is the observed interplay between four-fold bulk like in-plane magnetic anisotropy and two-fold uniaxial in-plane magnetic anisotropy. While the latter is dominant in ultrathin Fe films, the former is governing the thicker and bulk dimensions. [2] In-plane uniaxial anisotropy is believed to be caused by the interfacial phases and/or magnetoelastic strain. Magnetic anisotropy will be discussed in detail later on.

In this study, 5 nm thick Fe micro-dots have been successfully deposited onto the GaAs substrate by using the combination of lithography and e-beam evaporation techniques and magnetic properties have been discussed. Such microdots could be used in future magnetoelectric devices and MEMS.

2. Experimental

Fe micro-dots were synthesized by the lift-off process. GaAs (100) and Si (001) wafers were used as substrates. Substrates were spin-coated at a speed of 4000 rpm for 45 sec. with Az5214e photoresist. The coated resist was baked to harden at 105 °C for 1 min. Next, substrates were subjected to a UV-light (4.5 sec.) through the prefabricated mask with a pattern of 100 μ m diameter circles decorated 100 μ m apart. (Midas/MDA-60MS Mask Aligner 4') UV lights weaken the links of the exposed parts of the resist coating, which was later removed by 726 MIF developer. The prepared array of circular holes was filled by depositing (Torr E-beam and Thermal Evaporator) 50 nm Fe (deposition rate:0.1 nm/sec) (5 nm on GaAs) and 5 nm Cr cover layer (to prevent oxidation). The base pressure in the evaporation chamber was 1x10⁻⁶ mbar. (Scheme 1)

2.1 Characterization:

Morphology analyses of the samples were performed using Jeol JSM 6010. Magnetic measurements at room temperature were made with a Quantum Design VSM-SQUID. Structural characterizations were performed using Bruker D8 X-ray diffractometer (XRD) using a monochromatic Cu K α X-ray source.



Scheme. 1 Schematic of the experimental process.

3. Results and Discussion

In order to have a base data for the films deposited on GaAs, Fe continuous thin film and microdots (100 nm in diameter) with a thickness of 50 nm have been deposited onto Si wafers. Indexing of Fe continuous thin film's on Si and microdots on GaAs XRD scan confirmed the presence of α -Fe BCC phase (ICSD 44863; space group I m3m)[21]. (Figure 1)



Fig. 1 XRD data of Fe continuous thin film on Si (left) and microdots GaAs (right).

Room temperature hysteresis loops (in-plane) of the Fe continuous films and microdots revealed a soft magnetic behaviour (as expected [22]). (Figure 2) Loops have a square shape, corresponding to the easy axis of the film. Minor room temperature coercivities of 85 Oe and 65 Oe were also observed for Fe continuous films and microdots, respectively. Large Mr/Ms ratio of 0.9 and 0.8 has been observed for Fe continuous films and microdots, respectively, which is quite important for high-density recording media applications. [23]



Fig. 2 Room temperature hysteresis loops (in-plane) of Fe (a) continuous film, (b) microdots deposited on Si wafer.

After confirming the data for the continuous and micro-dot Fe films on Si wafers, Fe microdots were synthesized on GaAs substrates. To reduce the mismatch between Fe and GaAs films and increase the quality of epitaxy, the thickness of the micro-dots was limited to 5 nm. [1] Scanning electron microscopy (SEM) image of the Fe micro-dots shows that the structures were successfully synthesized. (Figure 3)



Fig. 3 SEM image of Fe micro-dots.

As it was stated earlier, the main focus of this work was toward seeing the effect of in-plane anisotropy in micro-dots. Ergo, both in-plane and out-of-plane hysteresis loops were taken at room temperature. While the loop taken in-plane has the characteristic of twophase/magnetic anisotropies behaviour with soft and hard ferromagnetic contributions $(RT H_c=300 \text{ Oe})$, the out-of-plane loop corresponds to the classical hard direction loop with a room temperature coercivity of 925 Oe. (Figure 4) The reason behind the shape of the inplane loop is the interplay between the two types of magnetic anisotropies; magnetoelastic and magneto-crystalline interface anisotropy. Whilst the latter is of interfacial origin thus due to the bonding of the Fe atoms with As atoms and reconfiguration according to the uniaxial symmetry of the substrate surface (surface anisotropy, [24-26]), the former is due to the anisotropic strain relaxation throughout the volume (anisotropic in-plane strain) of the thin film starting from compressive stress on the interface due to mismatch and later transforms to tensile due to the interfacial phase formation (Fe-Ga-As). These two different anisotropy effects form the basis of the term uniaxial in-plane magnetic anisotropy, ergo the reason behind the behaviour observed in the in-plane hysteresis loop of the Fe microdots deposited on GaAs substrate. [2]

On contrary, the out-of-plane loop is due solely to cubic anisotropy. It should be noted that thin-film shape anisotropy forces the magnetization to lie in-plane thus out-of-plane direction is hard. [2] It should also be noted that M_R/M_S ratio lower than 0.5 on in-plane and out-of-plane loops could be an indication for uniaxial anisotropy contribution produced by internal strains. [27,28]



Fig. 4 Room temperature hysteresis loops of Fe microdots deposited on GaAs substrate.

5. Conclusions

Fe/GaAs hybrid micro-structures were successfully synthesized by a combinatorial approach of lithography and e-beam deposition techniques. 50 nm and 5 nm of Fe was deposited onto Si (001) and GaAs (100) substrates, respectively. Continuous films and microdots were covered with 5 nm Cr to prevent oxidation. XRD scan confirmed the presence of α -Fe BCC phase (ICSD 44863; space group I m3m) on Fe continuous films and microdots deposited on Si and GaAs substrates, respectively. SEM image showed that the microdots (100 μ m diameter) were decorated throughout the wafer (100 μ m in between the microdot disks). Large Mr/Ms ratio of 0.9 and 0.8 has been observed for Fe continuous films and microdots deposited on Si substrate, respectively, which is quite important for high-density recording media applications. Moreover, minor room temperature coercivities of 85 Oe and 65 Oe were also observed for Fe continuous films and microdots deposited on Si substrate, respectively. While the loop taken in-plane has the characteristic of two-phase/magnetic anisotropies behaviour with soft and hard ferromagnetic contributions (room temperature Hc=300 Oe), the out-of-plane loop corresponds to the classical hard direction loop with a room temperature coercivity of 925 Oe. In-plane uniaxial magnetic anisotropy was observed similar to the a priori observed effects on continuous films. The underlying reason for the in-plane uniaxial magnetic anisotropy is postulated to be interfacial origin due to the interfacial mixing of Fe atoms and out-diffused GaAs substrate atoms (mainly As). In addition to the interfacial effects, anisotropic strain distribution causes a uniaxial magnetoelastic anisotropy in-plane. Furthermore, MR/MS ratio lower than 0.5 on in-plane and out-of-plane loops could be an indication for uniaxial anisotropy contribution produced by internal strains. Fabricated semi epitaxial Fe microdots could be used in magnetoelectronic devices and micro electro mechanic systems by further improving the interface quality, thus increasing the spin incision efficiency.

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